



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shunpei Yamazaki et al. Art Unit : Unknown  
Serial No. : 10/647,539 Examiner : Unknown  
Filed : August 26, 2003  
Title : SEMICONDUCTOR THIN FILM AND ITS MANUFACTURING METHOD  
AND SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Supplemental to an information disclosure statement filed with the application on August 26, 2003, Applicants submit the reference listed on the attached form PTO-1449.

This statement is being filed before the receipt of a first Office action on the merits.  
Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: February 2, 2004

  
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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-126004	Application No. 10/647,539
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary) (37 CFR 1.98(b))		Applicant Shunpei Yamazaki et al.	
		Filing Date August 26, 2003	Group Art Unit

**U.S. Patent Documents**

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

**Foreign Patent Documents or Published Foreign Patent Applications**

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation Yes <input type="checkbox"/> No <input checked="" type="checkbox"/>
	AL	08-255916	10/01/1996	JAPAN			Full <input type="checkbox"/>
	AM						
	AN						
	AO						
	AP						

**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	